

DOCKET NO: 295715US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

MASARU SASAKI, ET AL. : EXAMINER: MALEK, M.

SERIAL NO: 10/591,343 :

FILED: AUGUST 31, 2006 : GROUP ART UNIT: 2813

FOR: METHOD FOR MANUFACTURING :  
SEMICONDUCTOR DEVICE AND  
PLASMA OXIDATION METHOD

RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE EXAMINING  
GROUP 2813

AMENDMENT AND REQUEST FOR RECONSIDERATION

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Responsive to the Office Action of September 16, 2010, Applicants request  
reconsideration in view of the following amendment and remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on  
page 2 of this paper.

**Discussion of the Claims** begins on page 5 of this paper

**Remarks** begin on page 6 of this paper.